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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/647,742	08/25/2003	Mark P. Davidson	D1	D1 2294	
7:	590 04/21/2005		EXAMINER		
Michael L. Sherrard			TURNER, SAMUEL A		
72 Doud Drive Los Altos, CA			ART UNIT	PAPER NUMBER	
			2877		
		DATE MAILED: 04/21/2005			

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)		-01			
Office Action Commons	10/647,742	DAVIDSON, MAR	KP.	(Qu			
Office Action Summary	Examiner	Art Unit					
	Samuel A. Turner	2877					
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence ad	dress -	••			
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply If NO period for reply is specified above, the maximum statutory period w Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be timed within the statutory minimum of thirty (30) days will apply and will expire SIX (6) MONTHS from a cause the application to become ABANDONE	nely filed s will be considered time the mailing date of this or O (35 U.S.C. § 133).		ation.			
Status							
1) Responsive to communication(s) filed on 31 Ja	anuary 2005.						
	action is non-final.						
Since this application is in condition for allowance except for formal matters, prosecution as to the ments is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.							
Disposition of Claims							
4) Claim(s) <u>1-34</u> is/are pending in the application. 4a) Of the above claim(s) is/are withdraw 5) Claim(s) is/are allowed.							
6)  Claim(s) 1-13,19-27,33 and 34 is/are rejected.  7)  Claim(s) 14-18 and 28-32 is/are objected to.  8)  Claim(s) are subject to restriction and/or election requirement.							
Application Papers							
9) The specification is objected to by the Examine	r. ·						
10) ☐ The drawing(s) filed on is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.							
Applicant may not request that any objection to the	• • •						
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).							
11) ☐ The oath or declaration is objected to by the Ex	aminer. Note the attached Office	Action or form P1	O-152	2.			
Priority under 35 U.S.C. § 119							
12) Acknowledgment is made of a claim for foreign  a) All b) Some * c) None of:  1. Certified copies of the priority documents  2. Certified copies of the priority documents  3. Copies of the certified copies of the priority documents  application from the International Bureau  * See the attached detailed Office action for a list	s have been received. s have been received in Applicati rity documents have been receive u (PCT Rule 17.2(a)).	on No ed in this National	Stage				
Attachment(s)  I) M Notice of References Cited (PTO-892)  D Notice of Draftsperson's Patent Drawing Review (PTO-948)	4) Interview Summary Paper No(s)/Mail Da	ite					
3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date 1.0505.	5) Notice of Informal P	atent Application (PTC	D-152)				

#### **DETAILED ACTION**

## Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

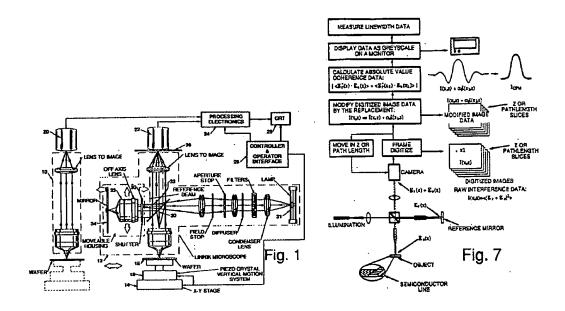
(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1-10, 19, 21-24, and 33 are rejected under 35 U.S.C. 103(a) as being unpatentable over Davidson et al(5,112,129) in view of See et al(Applied Optics, 12/1996).

Davidson et al teach an interference microscope comprising a broadband source(31), focusing optics, a Linnik microscope, An X-Y stage(14) with a vertical motion system(18), sample wafer(16) having grating structures, reference reflector(34), an imaging lens and camera(22) located at the image plane(36), see figure 1. The illumination from the source(31) is focused on the image plane of the microscope thus providing Koehler illumination of the sample. The wafer is displaced vertically and a plurality of images are captured by the camera and stored in memory, wherein each pixel of an image corresponds to a location on the wafer surface, see figure 7.

See et al teach an interference profilometer wherein the detector array records the back focal plane of the objective lens. The distributions at the front and back focal planes of the objective lens are related through Fourier transform. Thus each point on the back focal plane corresponds to a plane-wave component incident at the object surface at a particular angle, with the maximum angle limited by the N.A. of the lens. See figure 2 of See and page 6664.

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It would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the Davidson apparatus by imaging the back focal plane instead of the object image plane because each point on the back focal plane corresponds to a plane-wave component incident at the object surface at a particular angle.

Claims 1-12, 19-26, 33, and 34 are rejected under 35 U.S.C. 103(a) as being unpatentable over deGroot(5,398,113) in view of See et al(Applied Optics, 12/1996).

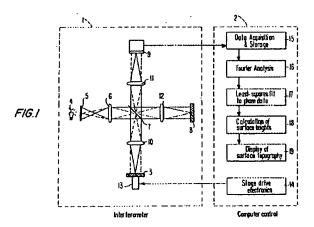
The deGroot patent teaches a coherence microscope comprising a broadband source(4), focusing optics(6), beam-splitter(7), microscope optics(10,12), a sample(3) located on transducer(13), reference reflector(8), imaging lens(11), CCD array(9), and a computer(2), see figure 1. The illumination from the source(4) is focused on the image plane of the microscope thus providing Koehler illumination of the sample. The computer includes capturing a plurality of images as the sample is displaced and storing each image in memory, wherein each pixel of an image corresponds to a location on the sample surface, and a Fourier transform is applied to each image thus applying the principles of frequency-domain analysis to topography. Note that a

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quasi-monochromatic source with a high numerical aperture can be used as the illumination source, column 8, lines 66+.

See et al teach an interference profilometer wherein the detector array records the back focal plane of the objective lens. The distributions at the front and back focal planes of the objective lens are related through Fourier transform. Thus each point on the back focal plane corresponds to a plane-wave component incident at the object surface at a particular angle, with the maximum angle limited by the N.A. of the lens. See figure 2 of See and page 6664.



It would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the deGroot apparatus by imaging the back focal plane instead of the object image plane because each point on the back focal plane corresponds to a plane-wave component incident at the object surface at a particular angle.

Claims 12, 13, 20, 25-27, and 34 are rejected under 35 U.S.C. 103(a) as being unpatentable over Davidson et al(5,112,129) and See et al(Applied Optics, 12/1996) as applied to claims 1-10, 19, 21-24, and 33 above, and further in view of deGroot(5,398,113).

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It would have been obvious to one of ordinary skill in the art at the time the invention was made to modify the Davidson apparatus to applying the principles of frequency-domain analysis to tomography to improve the tomographic measurements.

### Response to Arguments

Applicant's arguments with respect to claims 1-13, 19-27, 33, and 34 have been considered but are most in view of the new ground(s) of rejection.

#### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Samuel A. Turner whose phone number is 571-272-2432.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gregory J. Toatley, Jr., can be reached on 571-272-2800 ext. 77.

The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <a href="http://pair-direct.uspto.gov">http://pair-direct.uspto.gov</a>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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